Ref No : IJRAR/Vol   / Issue   / 007

To,
Abhishek Chauhan
Publication Date 2020-05-27 03:31:26

Subject: Publication of paper at International Journal of Research and Analytical Reviews (IJRAR).

Dear Author,

With Greetings we are informing you that your paper has been successfully published in the International Journal of Research and Analytical Reviews (IJRAR) - IJRAR (E-ISSN 2348-1269, P- ISSN 2349-5138). Thank you very much for your patience and cooperation during the submission of paper to final publication Process. It gives me immense pleasure to send the certificate of publication in our Journal. Following are the details regarding the published paper.

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UGC Approval : UGC Approved Journal No: 43602
Registration ID : IJRAR_220516
Paper ID   : IJRAR1BMP007
Title of Paper : A NOVEL DESIGN OF RF MEMS SWITCH WITH REDUCTION IN THE STRESS GRADIENT AND COMTACT FORCE TO INCREASE RELIABILITY
Impact Factor : 7.17 (Calculate by Google Scholar) | License by Creative Common 3.0
DOI   :
Published in   : Volume | Issue |
Publication Date: 2020-05-27 03:31:26
Page No   :
Published URL : http://www.ijrar.org/viewfull.php?&p_id=IJRAR1BMP007
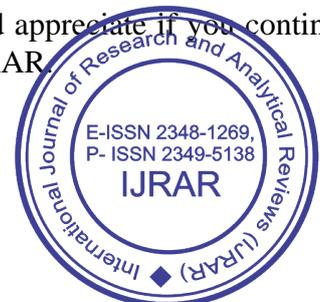Authors   : Abhishek Chauhan, Harpreet Singh

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(E-ISSN 2348-1269, P- ISSN 2349-5138)